

684.2745

PATENT APPLICATION#18/D  
6/26/01  
18

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

NAOTO SANO, ET AL.

Appln. No.: 09/163,402

Filed: September 30, 1998

For: GAS LASER DEVICE AND  
EXPOSURE APPARATUS USING  
THE SAMEDirector, the Commissioner for Patents  
Washington, D.C. 20231

Examiner: L. Scott, Jr.

Group Art Unit: 2881

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JACK S. CUBERT

Jack S. Cubert

Signature

SUPPLEMENTAL PRELIMINARY AMENDMENT

Sir:

Prior to its examination and supplemental to the preliminary amendment filed May 21, 2001, please amend the above-identified application as follows:

IN THE ABSTRACT:163402  
Please replace the present Abstract of the Disclosure with the following:

--In a gas laser device, a laser gas sealingly stored in a chamber is

excited using a discharging electrode that is electrically discharged. Laser light produced by the electrical discharging is totally reflected by a total reflection mirror. An output window partially reflects the laser light and